

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) <b>03680036AA</b>		Application Number <b>10/575,785</b>	
				Applicant(s) <b>Kensuke TAKAHASHI</b>			
				Filing Date <b>April 14, 2006</b>		Group Art Unit <del>2042</del>	

  

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

  

U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/S.W.S./		US2003/0143825 A1	07/31/2003	Matsuo et al.	438	585	12/23/2002

  

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

  

OTHER DOCUMENTS		<i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>
/S.W.S./		A copy of an Office Action issued by the Chinese Patent Office on September 14, 2007, in regard of the related application with English and Japanese language translations, pages 1 to 18

  

EXAMINER     /Stephen W. Smoot/	DATE CONSIDERED     08/11/2008
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.